

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Toru KIMURA, et al.

SERIAL NO: 10/539,571

GAU: 3781

FILED: June 17, 2005

EXAMINER: Robin HYLTON

FOR: VACUUM CONTAINER APPARATUS USED FOR MANUFACTURING
SEMICONDUCTOR DEVICES AND LID APPARATUS FOR SAME

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

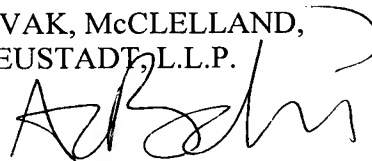
It is hereby requested that a **two** month extension of time be granted to January 5, 2010 for

- ☐ filing a response to the Official Action dated:
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☒ filing a Request for Continued Examination and an Amendment. A timely response to the final rejection, due November 5, 2009, has been filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27.

The required fee of \$490.00 is being made by credit card payment online (if electronically filed), or is attached hereto (if paper filed), and any further charges may be made against the Attorney of Record's Deposit Account No. **15-0030**.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, L.L.P.



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